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LINDA E. HASTINGS

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Toru TATSUMI

Serial No.: 09/744,701

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF  
METAL OXIDE DIELECTRIC FILM AND  
APPARATUS FOR VAPOR PHASE GROWTH OF  
METAL OXIDE DIELECTRIC MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

S I R :

In response to the Office Action mailed on April 29, 2004, (hereinafter referred to as "the Office Action"), and the Advisory Action mailed on August 23, 2004, (hereinafter referred to as "the Advisory Action"), the period for responding to the Office Action not being extended for more than three months, please amend the subject application as follows: